



PATENT  
3313-1048P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: CHEN, I-Cherng et al. Conf.: 6047  
Appl. No.: 10/690,503 Group: 1775  
Filed: October 23, 2003 Examiner: Cathy F.F. LAM  
For: MATERIAL WITH SURFACE NANOMETER FUNCTIONAL  
STRUCTURE AND METHOD OF MANUFACTURING THE  
SAME

**REPLY UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. BOX 1450  
Alexandria, VA 22313-1450

June 14, 2005

Sir:

In response to the Examiner's Office Action dated February 14, 2005 and in view of the Request for Continued Examination (RCE) being filed concurrently herewith, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes  
Amended Claim set; and  
Remarks.